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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

jc872 U.S. PRO
10/053785
01/18/02

In re Application of:)
Chen et al.) Group No.: 1741
Serial No.: (unknown) 10/053785) Examiner: (unknown) Valentine
Filed: (herewith) 1-18-01) Docket No. SJO920000194US1
For: A METHOD FOR ELECTROPLATING A)
BODY-CENTERED CUBIC NICKEL-IRON)
ALLOY THIN FILM WITH A HIGH)
SATURATION FLUX DENSITY)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

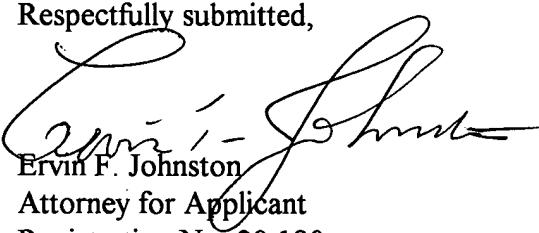
INFORMATION DISCLOSURE STATEMENT

Applicants hereby cite the documents listed in accompanying Form PTO-1449 with respect to the above-referenced patent application under the provisions of 37 C.F.R., Sections 1.56, 1.97 and 1.98. Copies of the documents are attached.

The filing of this Information Disclosure Statement will not be construed to mean that a search was conducted or that no other material information, as defined by 37 C.F.R. 1.56, exists.

The Examiner is respectfully requested to make the listed documents of record in connection with the prosecution of the subject application.

Respectfully submitted,

By: 
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Date: 11/5/01